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<b>13. SUPPLEMENTARY NOTES</b>					
<b>14. ABSTRACT</b> A micro electro mechanical system (MEMS) was designed, manufactured, and vibrationally tested. The system consisted of a multitude of nearly identical shear stress sensors. The resonant frequency was measured to 57 sensors with a mean frequency of 90.037 KHZ and a standard deviation of 0.297 KHZ. Although attempted in water, only the air measurements were conducted.					
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<b>a. REPORT</b> U	<b>b. ABSTRACT</b> U	<b>c. THIS PAGE</b> U			<b>19b. TELEPHONE NUMBER (Include area code)</b> 814-863-3029

# MEMS Shear Stress Sensor

Presented to Dr. Ron Joslin, ONR

Presented by Dr. Michael Jonson and Dr. Aman  
Haque, Mr. Amit Desai, Mr. Benedict Samuel  
and Mr. Todd Ziegler  
December 21, 2005

# Statement of Work

Objective	Result
Measure sensor-to-sensor variability:	<ul style="list-style-type: none"> <li>• Resonant frequency was determined for 57 sensors.</li> <li>• Mean Resonant Frequency = 90.037 KHz</li> <li>• Standard Deviation = 0.297 KHz</li> </ul>
Measure effects of fluid loading:	<ul style="list-style-type: none"> <li>• Resonant Frequency was determined for air and water</li> <li>• Resonant Frequency for Air = 90.037 KHz</li> <li>• Resonant Frequency for Water = ????? KHz</li> </ul>

# Agenda

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- Research Presentation
  - Objectives
  - Approach
  - Shear stress sensor design
  - Manufacturing Method
  - Experimental Results
  - Future Work



## Objective

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- Fabrication of MEMS shear stress sensor.
  - Investigate sensor-to-sensor stiffness variability.
  - Investigate effect of fluid loading.

## Approach

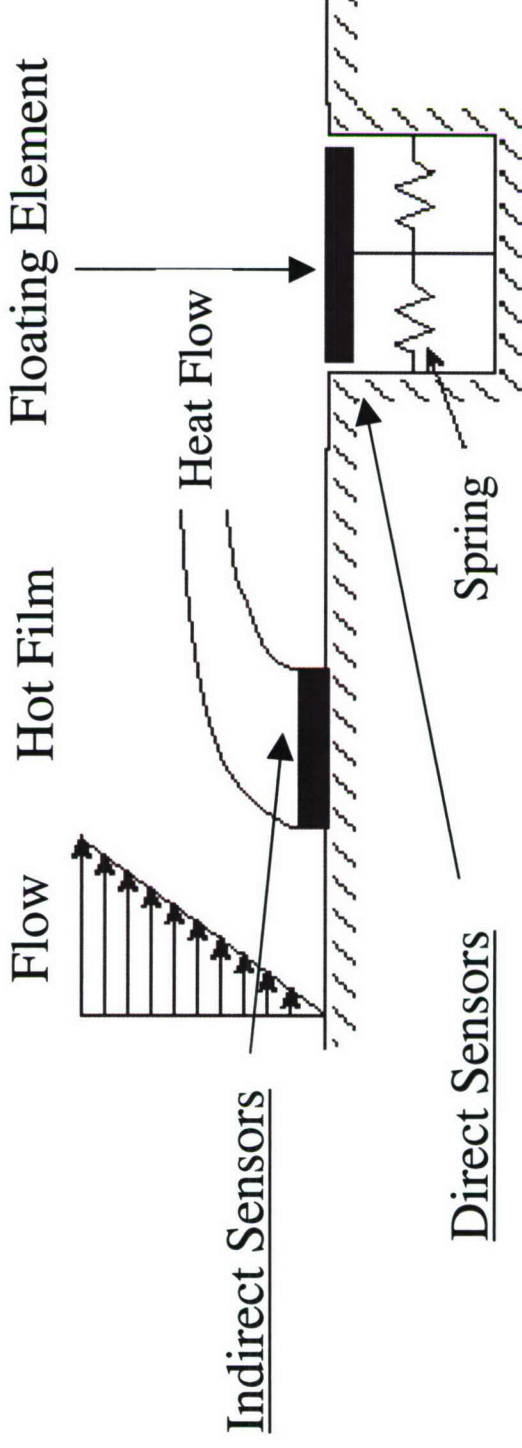
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1. Design and fabricate an array of MEMS shear stress sensors
2. Shake sensors and base over frequency range encompassing regions below and above the in-plane resonance frequency
3. Conduct measurements in air and water.

# Sensor Design Approaches

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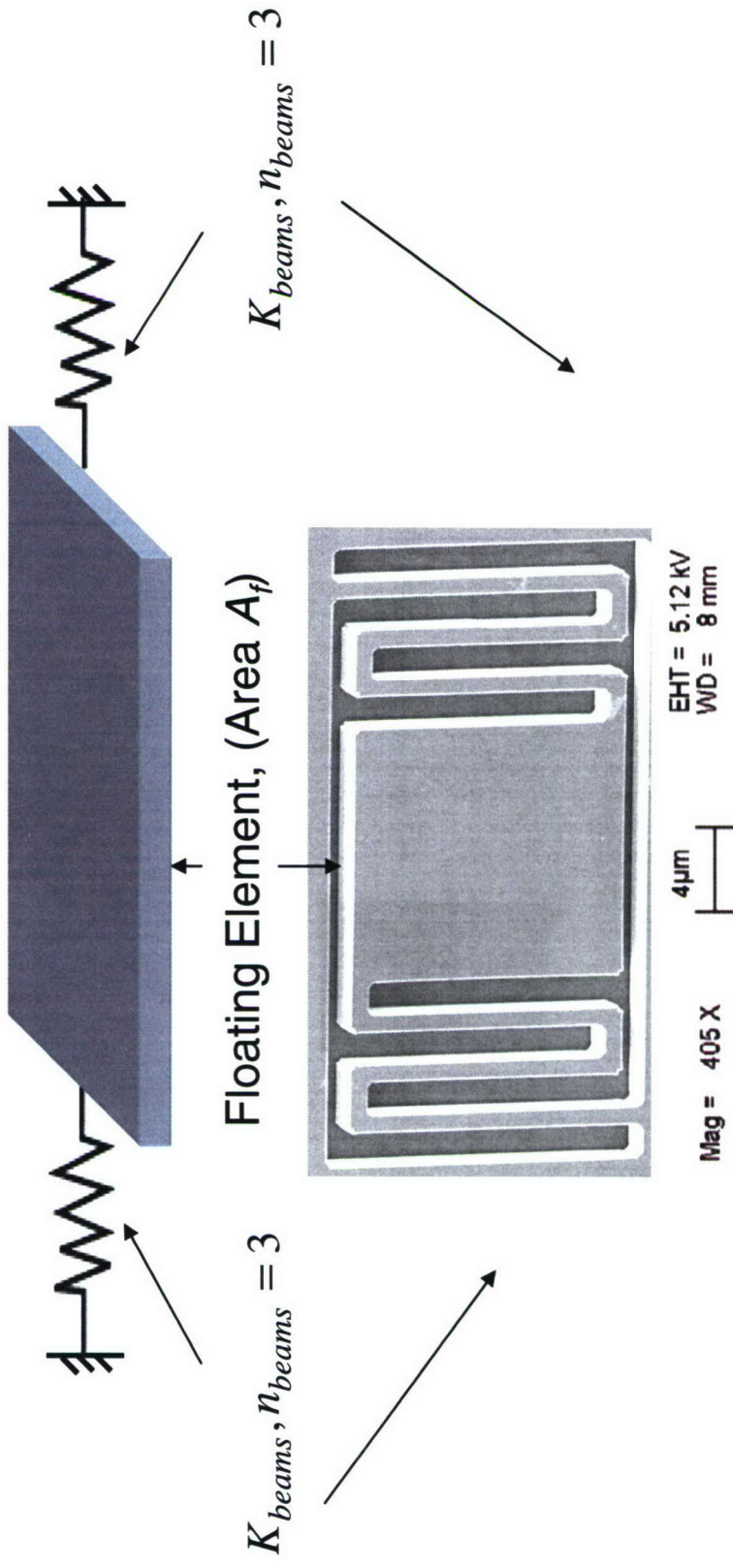
- Broadly classified as direct and indirect sensors.



- Direct type sensor is being designed

# Design Philosophy

- Size of the plate comparable to length scale.
- Number of beams and mass of plate control sensitivity and dynamic characteristics.



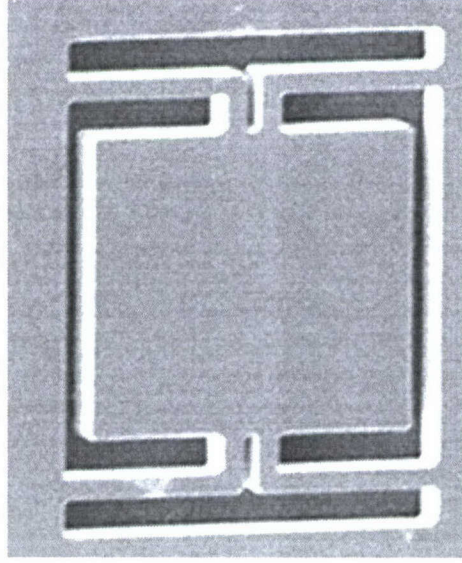
$$K_{device} = 2K_{beams} = \frac{1}{n_{beams}} \frac{24EI_{beam}}{l_{beam}^3} \cdot f_{natural} = \frac{1}{2\pi} \sqrt{\frac{K_{device}}{m_{device}}}$$



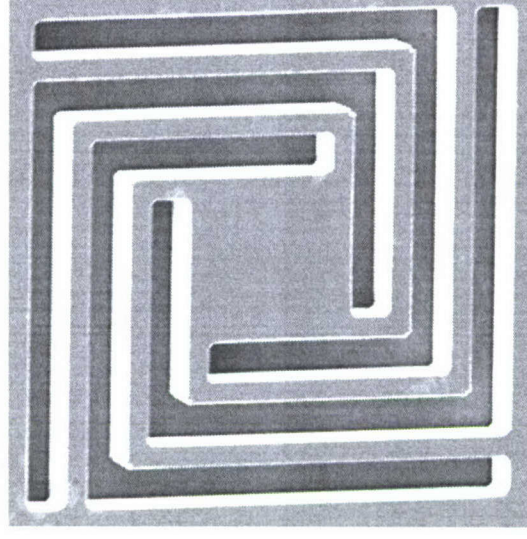
# Sensor Designs

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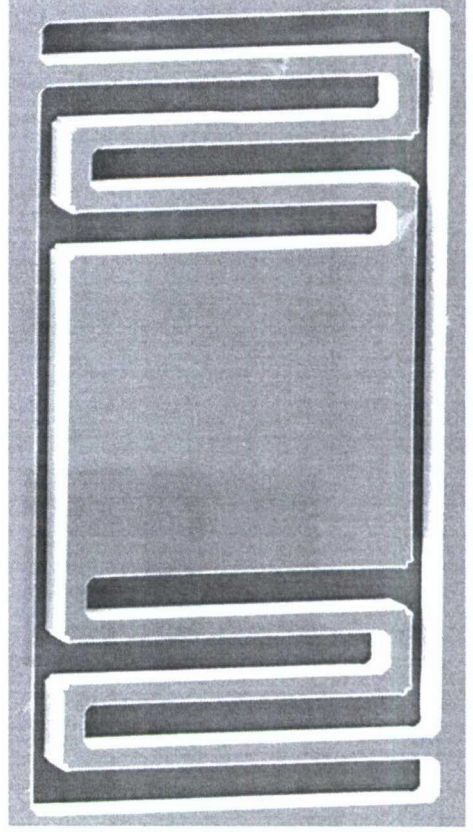
Design 1



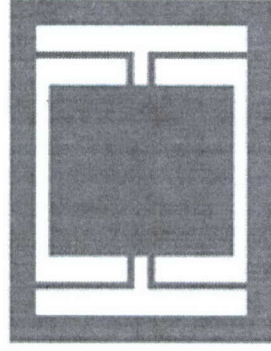
Design 2



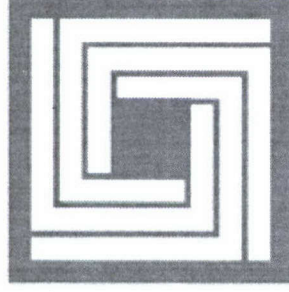
Design 3



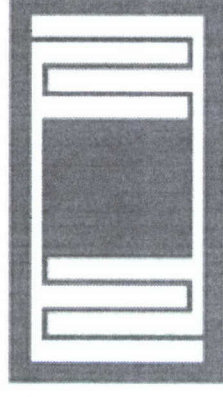
# Sensor Performance Estimates



Design 1



Design 2

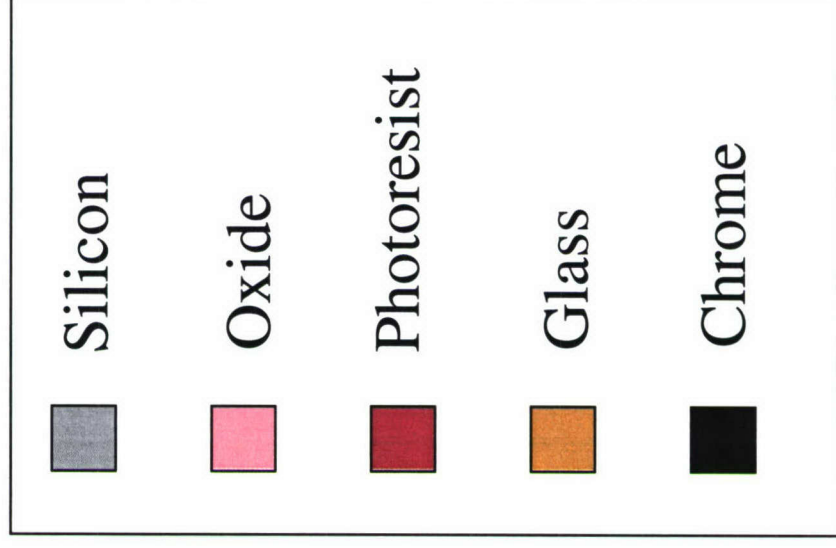
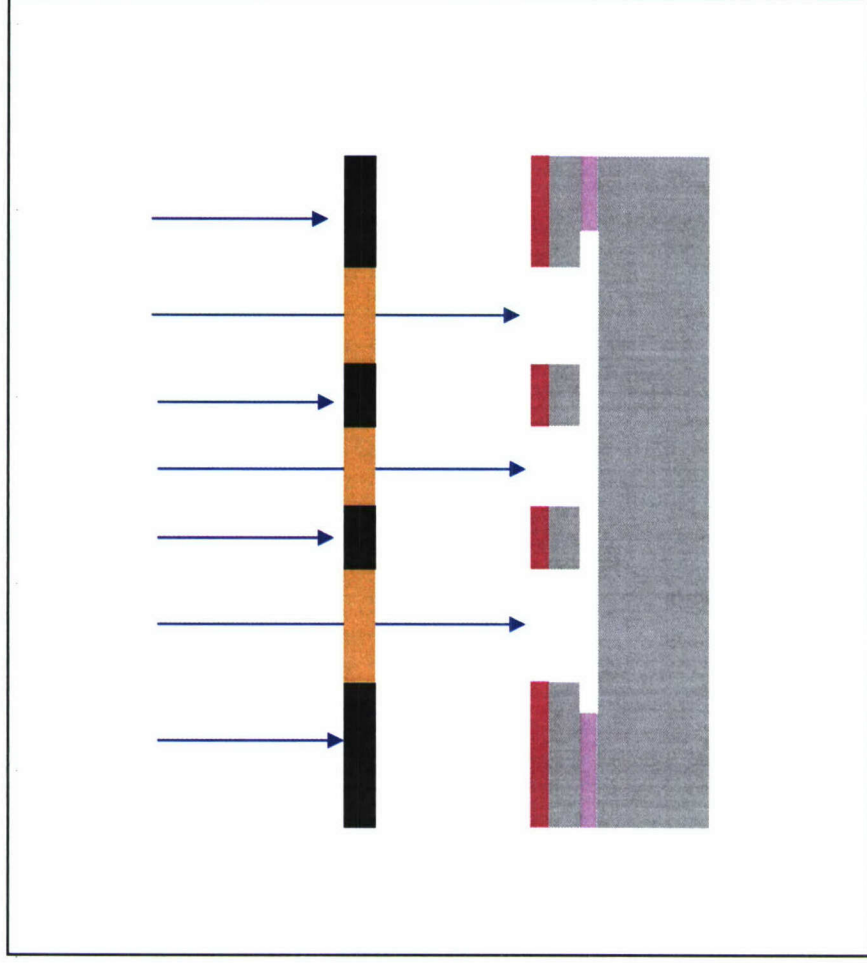


Design 3

## ANSYS Modal Analysis

Design No.	Floating element area, $A_f$ ( $\mu\text{m}^2$ )	Spring constant, $K_{\text{device}}$ (N/m)	Natural frequency, $\omega_r$ (MHz)	Frequency 1 (MHz)	Frequency 2 (MHz)	Frequency 3 (MHz)
1.	182.25	503.7	3.29	3.527	6.301	8.616
2.	121	51.87	1.09	0.954	0.954	1.462
3.	144	20.5	0.69	0.628	1.12	1.33

# Fabrication Process

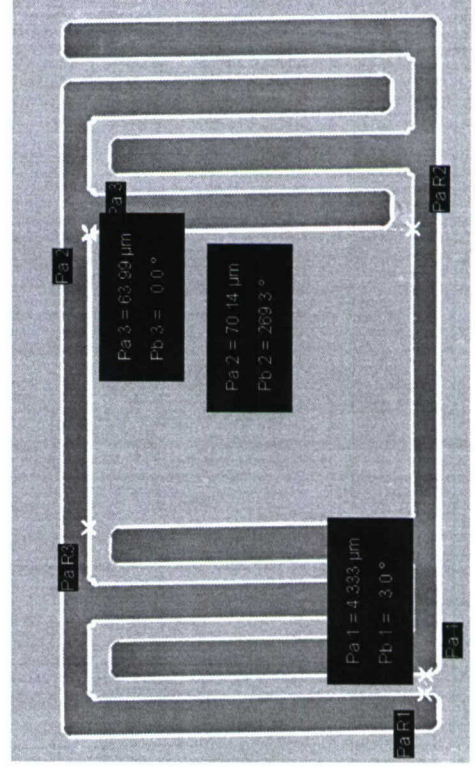
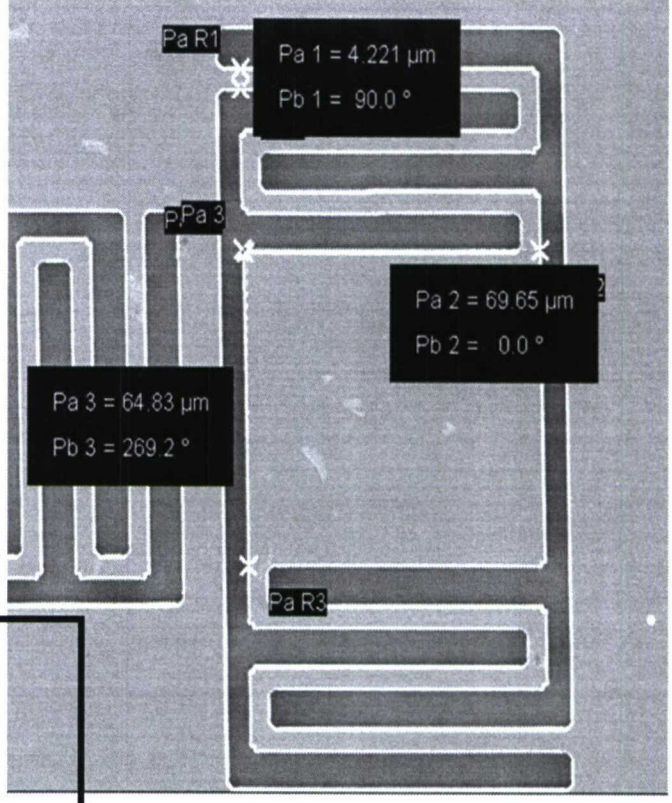




# Fabrication Uniformity

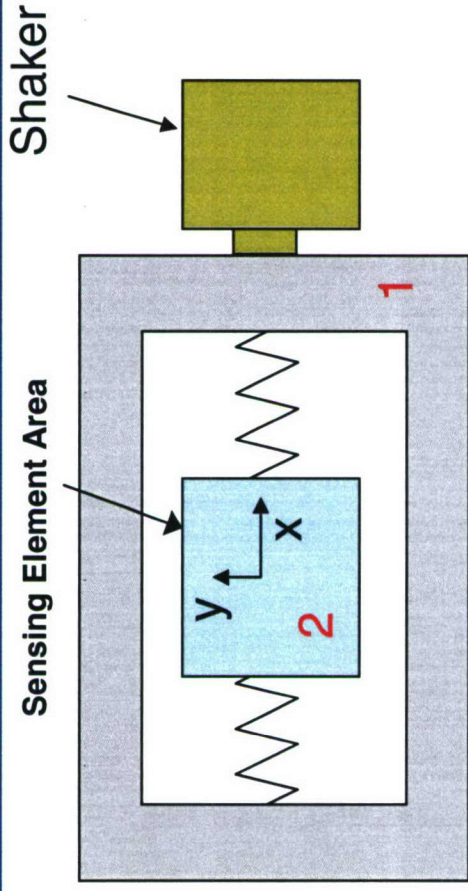
Dimension (Design 3)	Dimension variation (%)	Expected Stiffness variation (%)	Expected Frequency variation (%)
Beam Length	1.3	3.75	1.1
Beam width	2.35	7.05	4.6

Variation in dimensions for 2 different sensors





# Property variations

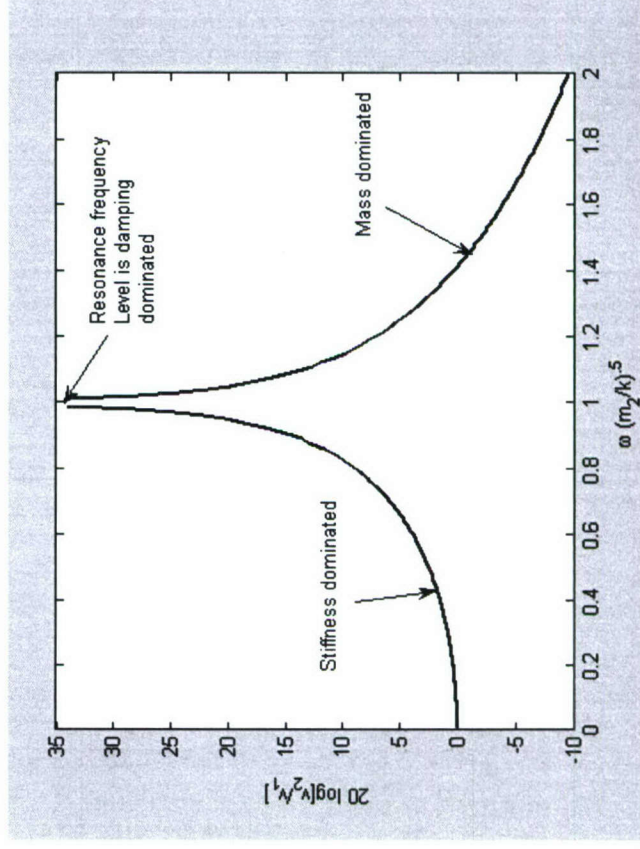


$$\omega_0 = (k/m)^{1/2}$$

$$\frac{d\omega_0}{\omega_0} = \frac{1}{2} \frac{dk}{k} - \frac{1}{2} \frac{dm}{m}$$

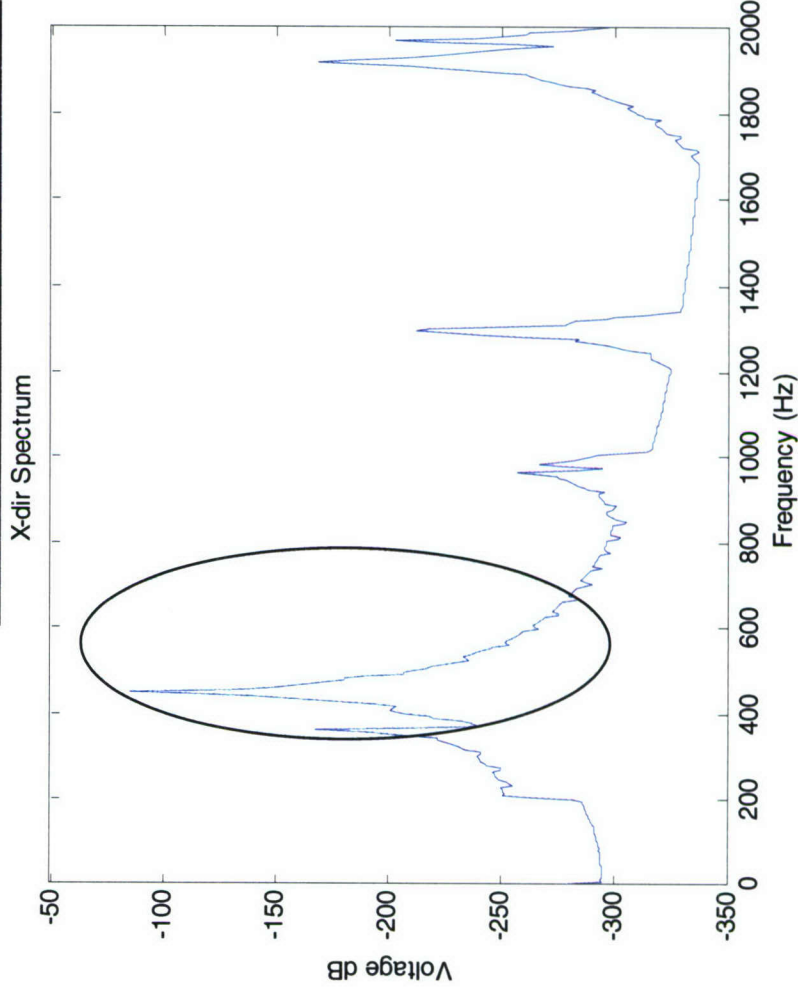
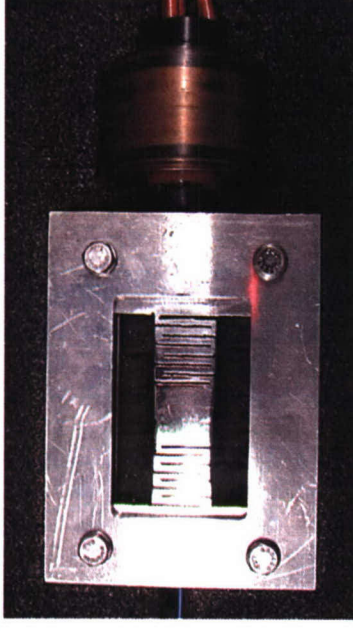
$$\frac{dk}{k} = 2 \frac{d\omega_0}{\omega_0} + \frac{dm}{m}$$

Variations in the stiffness will be assessed indirectly through measured variations in resonance frequency and mass variations.



# Scaled Model Testing

- Scaled prototype manufactured
  - Rough cut from Al at 450:1 scale
  - Investigate measurement method at macroscopic scale

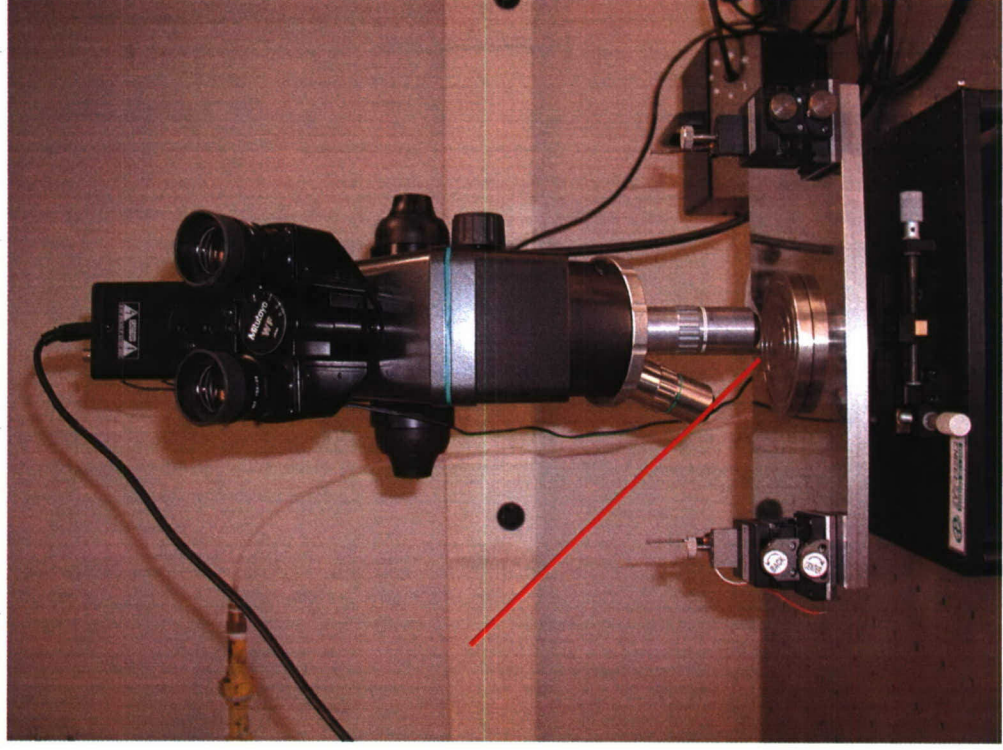
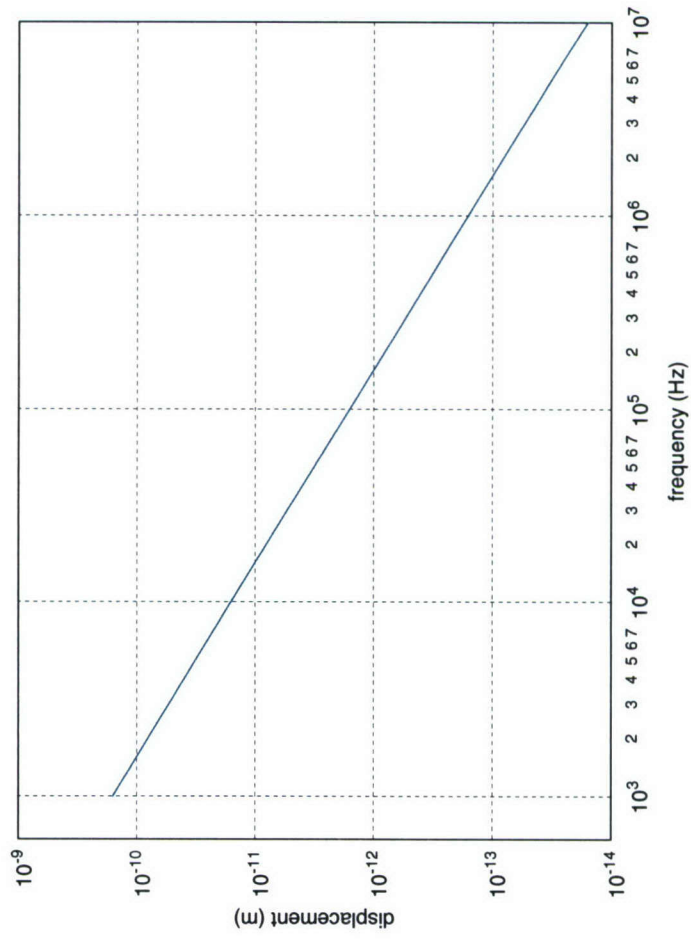


## ANSYS Modal Analysis

Actual Model	112.3 KHz
Scaled Model	141 Hz

# Vibrometer Resolution

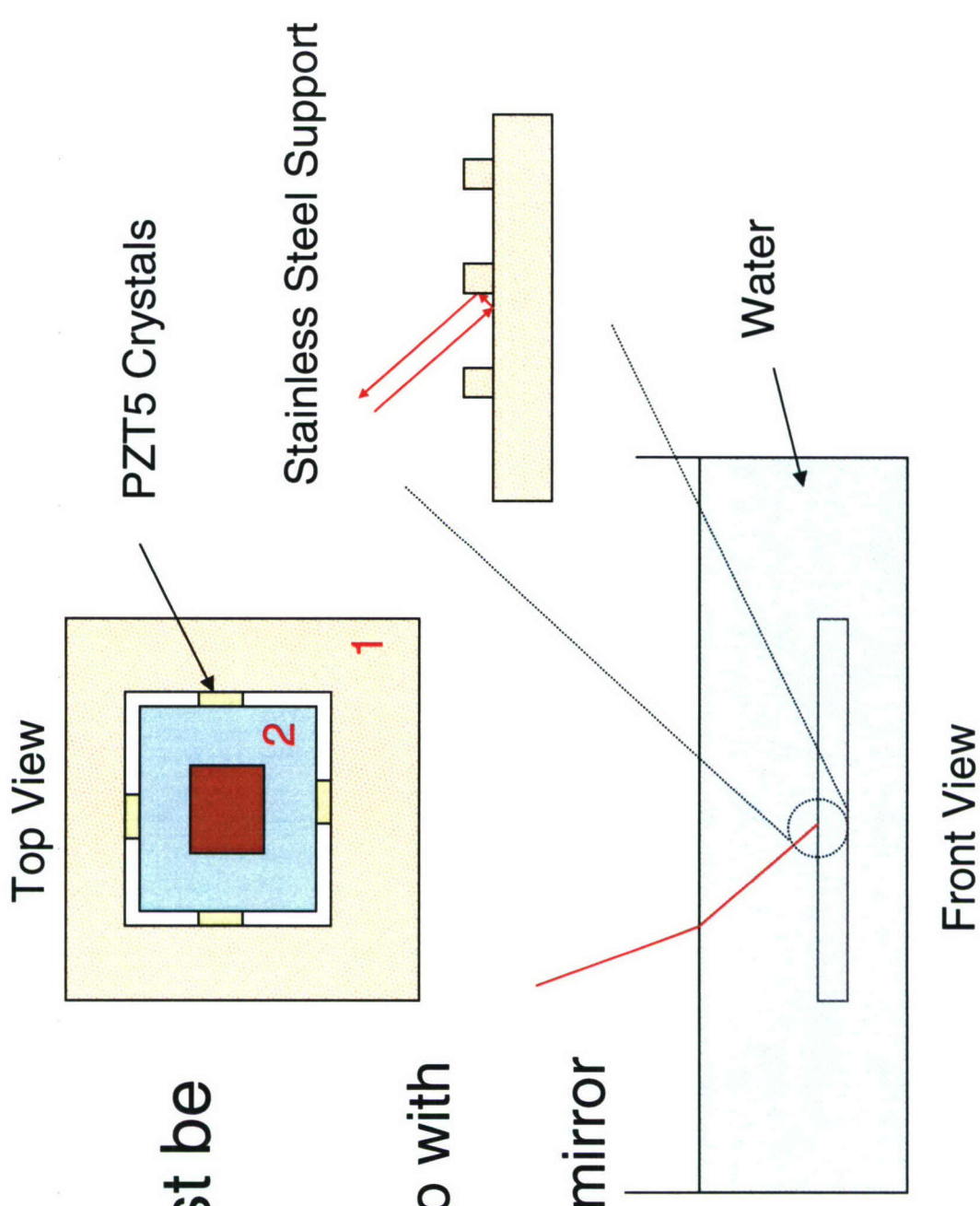
Vibrometer Extreme Minimum Resolution





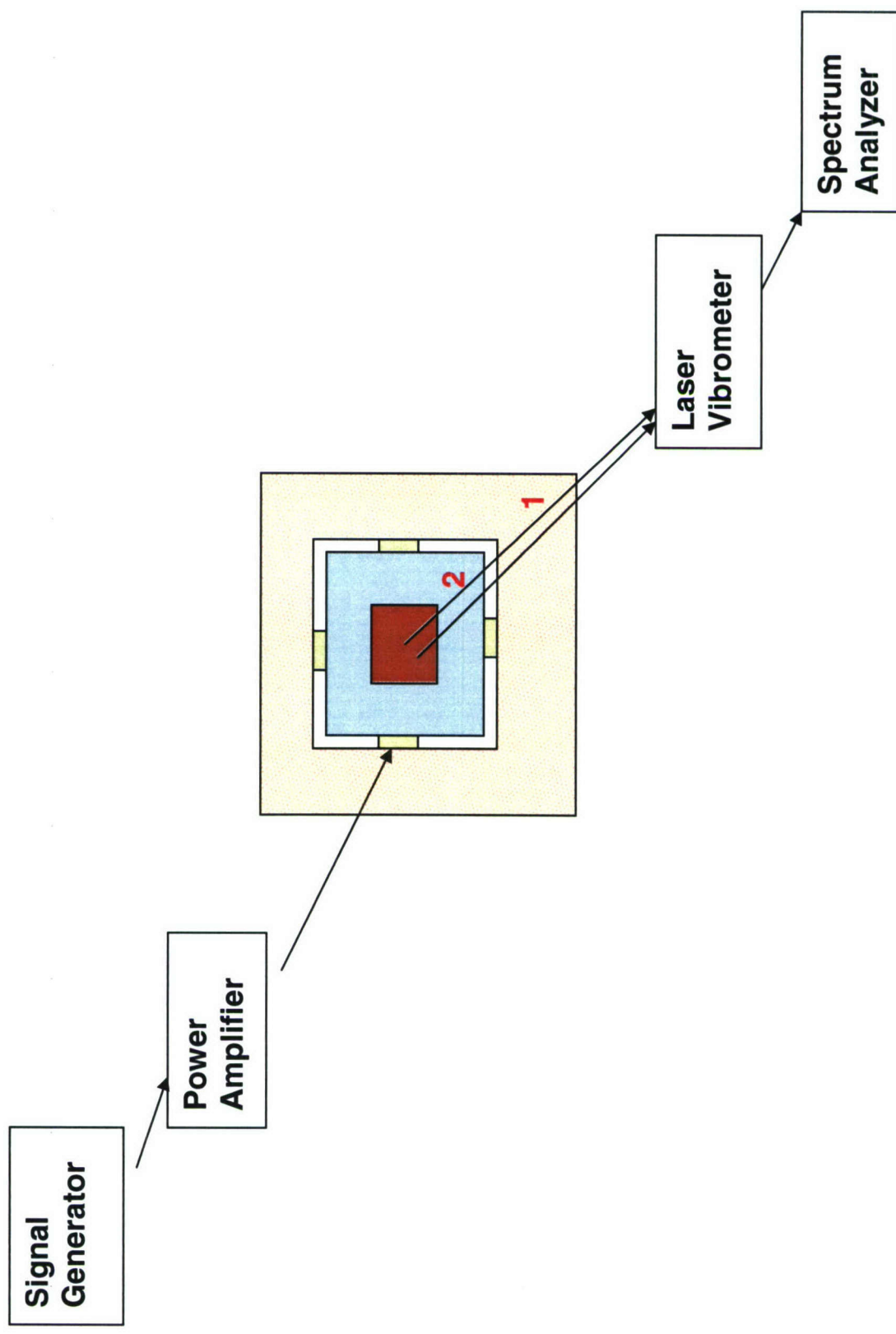
# Proposed Laser Vibrometer Optics

- Transverse vibration must be measured
  - Backscatter insufficient to with silicon
  - Right angle mirror approach ongoing





# Measurement System Design



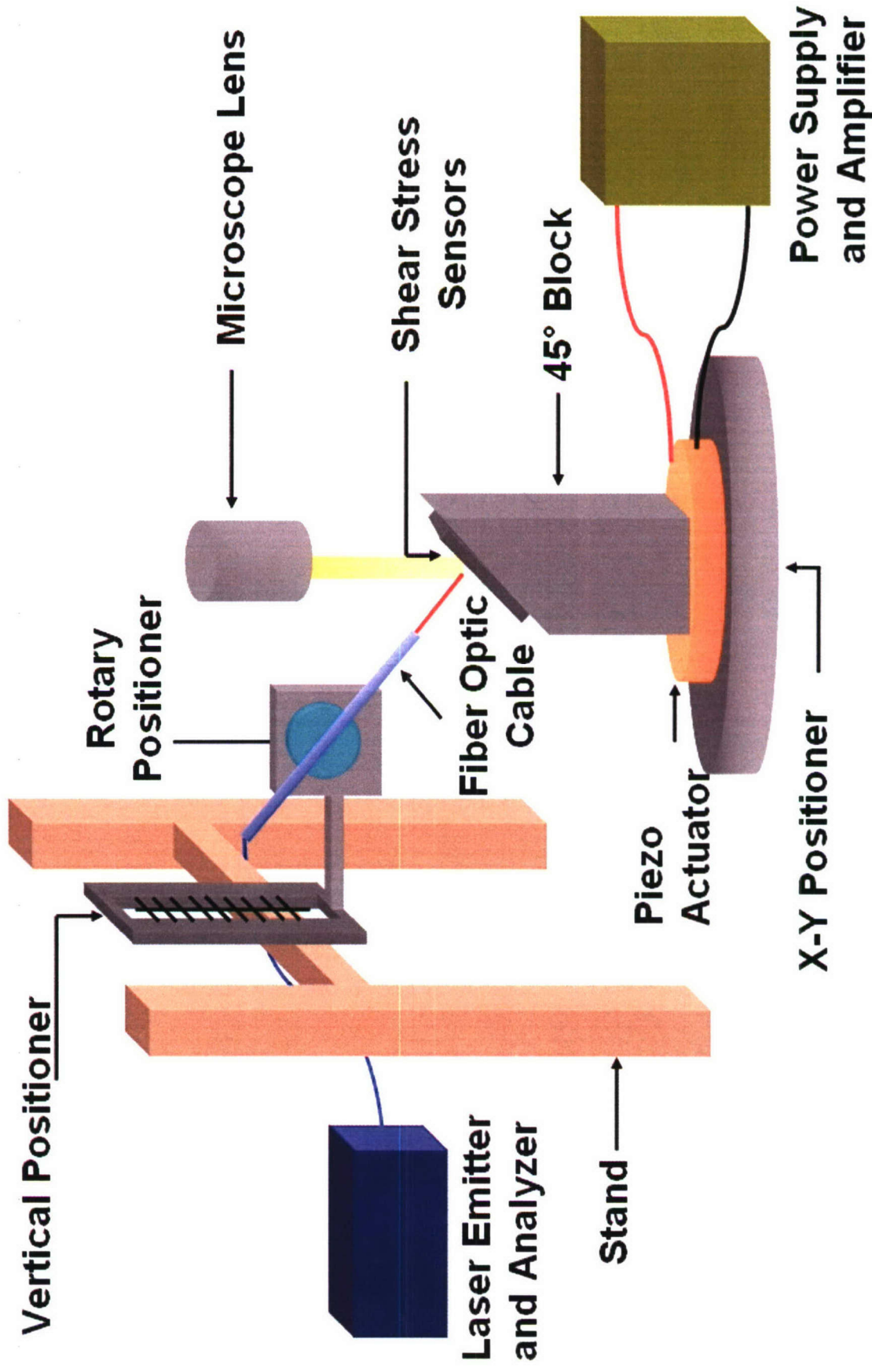


# Statement of Work

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- 1. Investigate sensor-to-sensor stiffness variability.**
- 2. Investigate effect of fluid loading.**

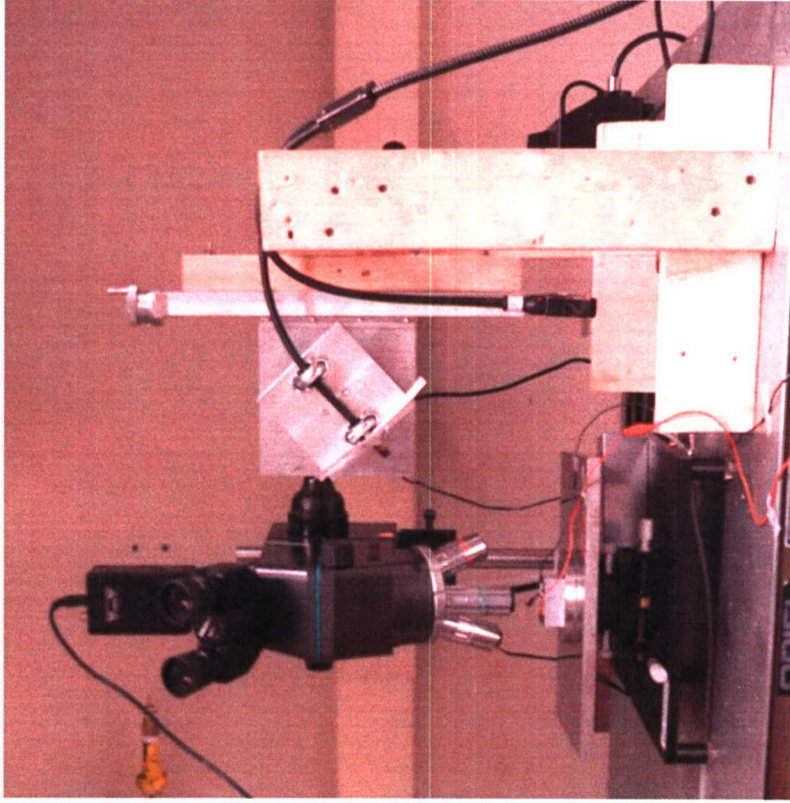
# S.O.W 1 - Experimental Setup for Testing in Air





# S.O.W 1 - Experimental Setup for Testing in Air

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Microscope and the Vibrometer



Signal Generator, Amplifier and the Vector  
Signal Analyzer



## S.O.W. 1 - List of Equipment

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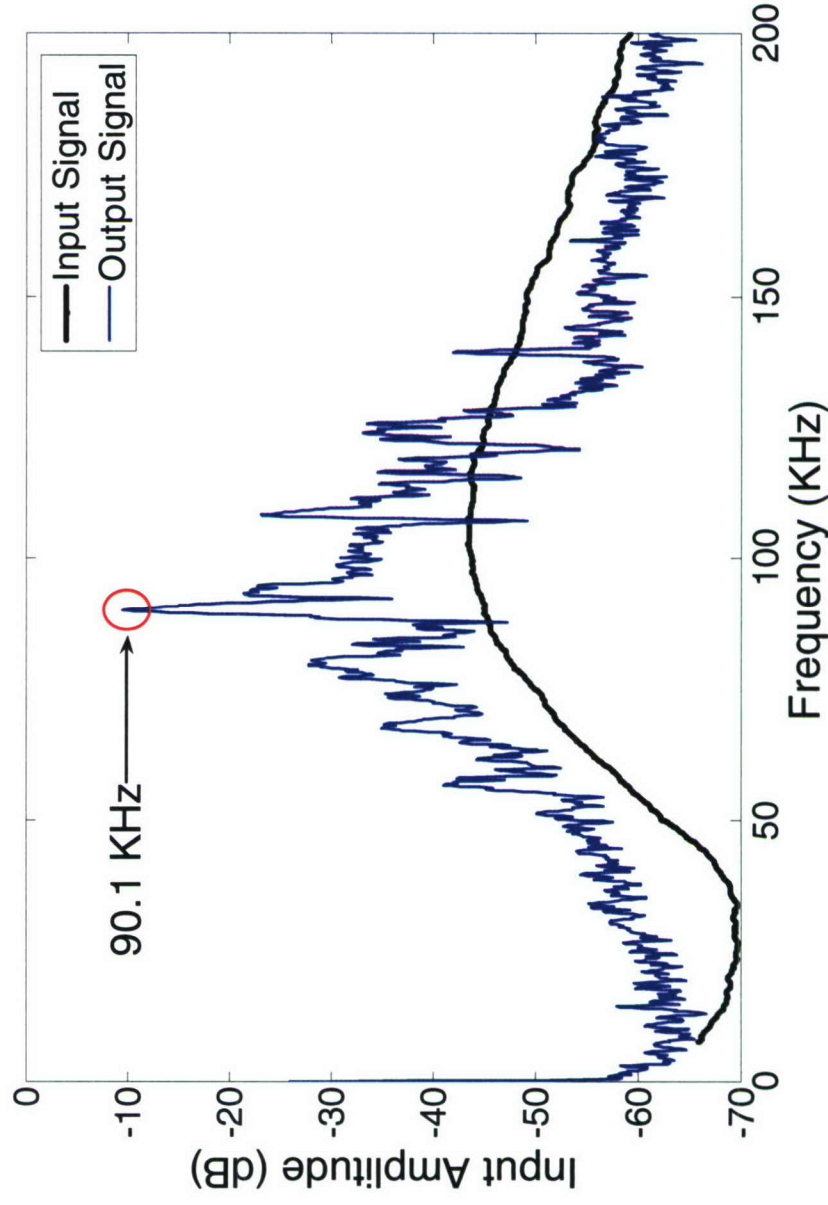
- Polytec Laser Vibrometer, OFV-2200 and OFV-303.
- Stanford Research Systems DS345 Function Generator.
- Krohn-Hite 7500 Amplifier.
- Agilent 89410A Vector Signal Analyzer.
- Mitutoyo Optical Microscope.
- CTS PZT 5A & 5H Piezoelectric Actuator



# S.O.W. 1 - Experimental Results for Sensor Vibration in Air

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- Filtered white noise input.
- Analyzed the frequency spectrum.





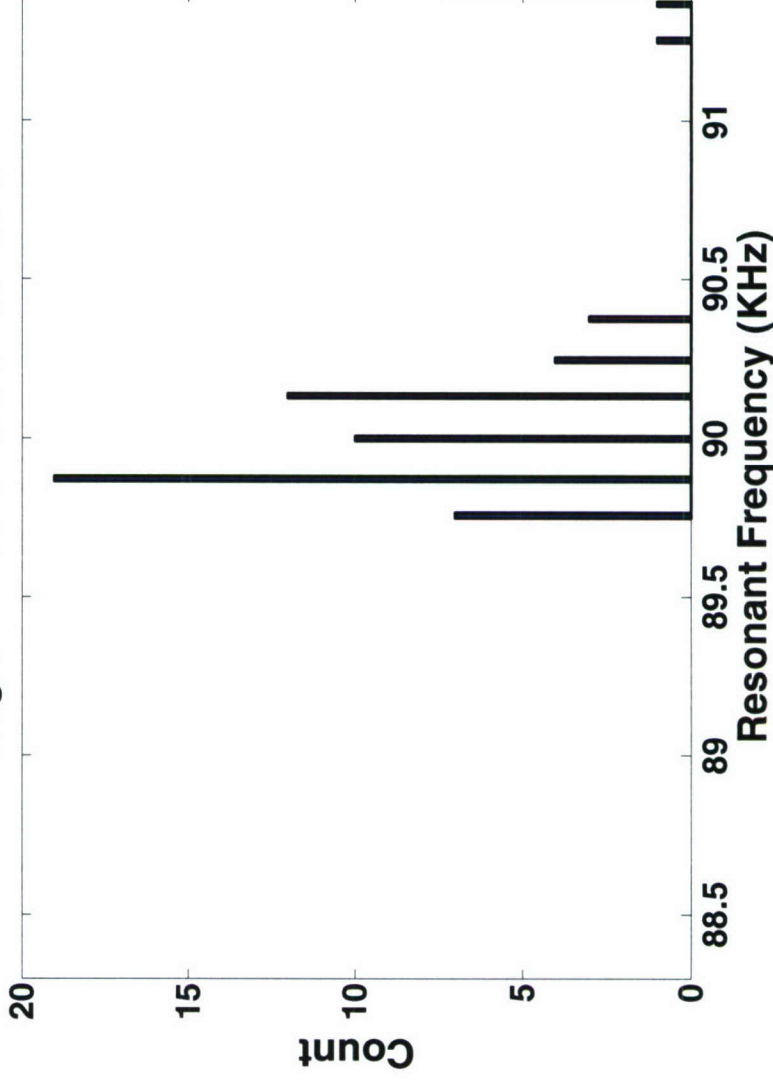
# S.O.W. 1 - Experimental Results for Sensor Vibration in Air

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Performed experiments on 57 sensors

- Mean Resonant Frequency = 90.037 KHz
- Standard Deviation = 0.297 KHz

Histogram Plot for the 57 sensors







# S.O.W. 1 - Experimental Results for Sensor Vibration in Air

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There is a 19.8 % decrease in resonant frequency from design value (112.3 KHz) due to

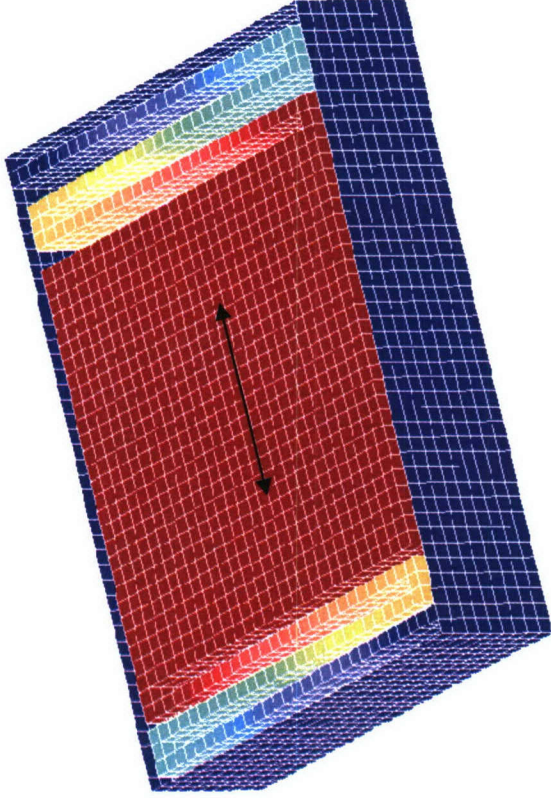
- fabrication processes,
- material properties,
- squeeze film damping.

However the variation among different sensors is small and it suffices to calibrate 2 to 3 sensors only.

## S.O.W. 2 - Effects of fluid loading

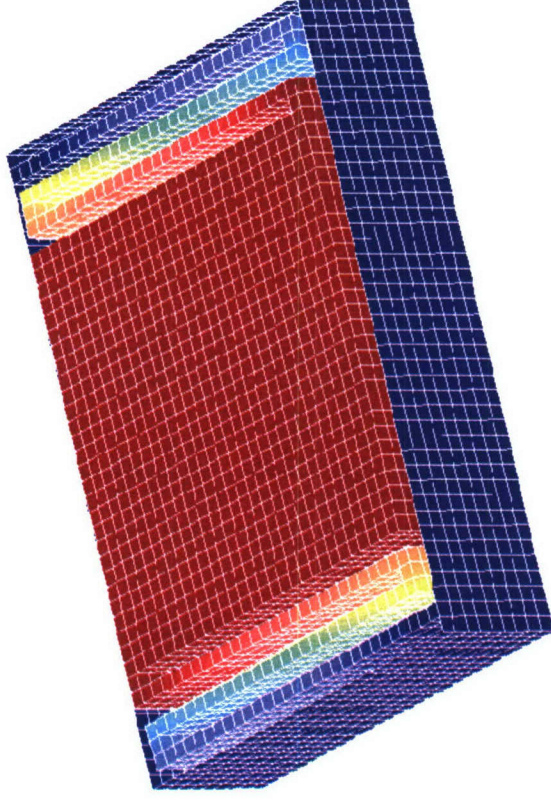
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In Vacuo: 407.7 kHz  
In Water: 379.6 kHz



Shear Motion

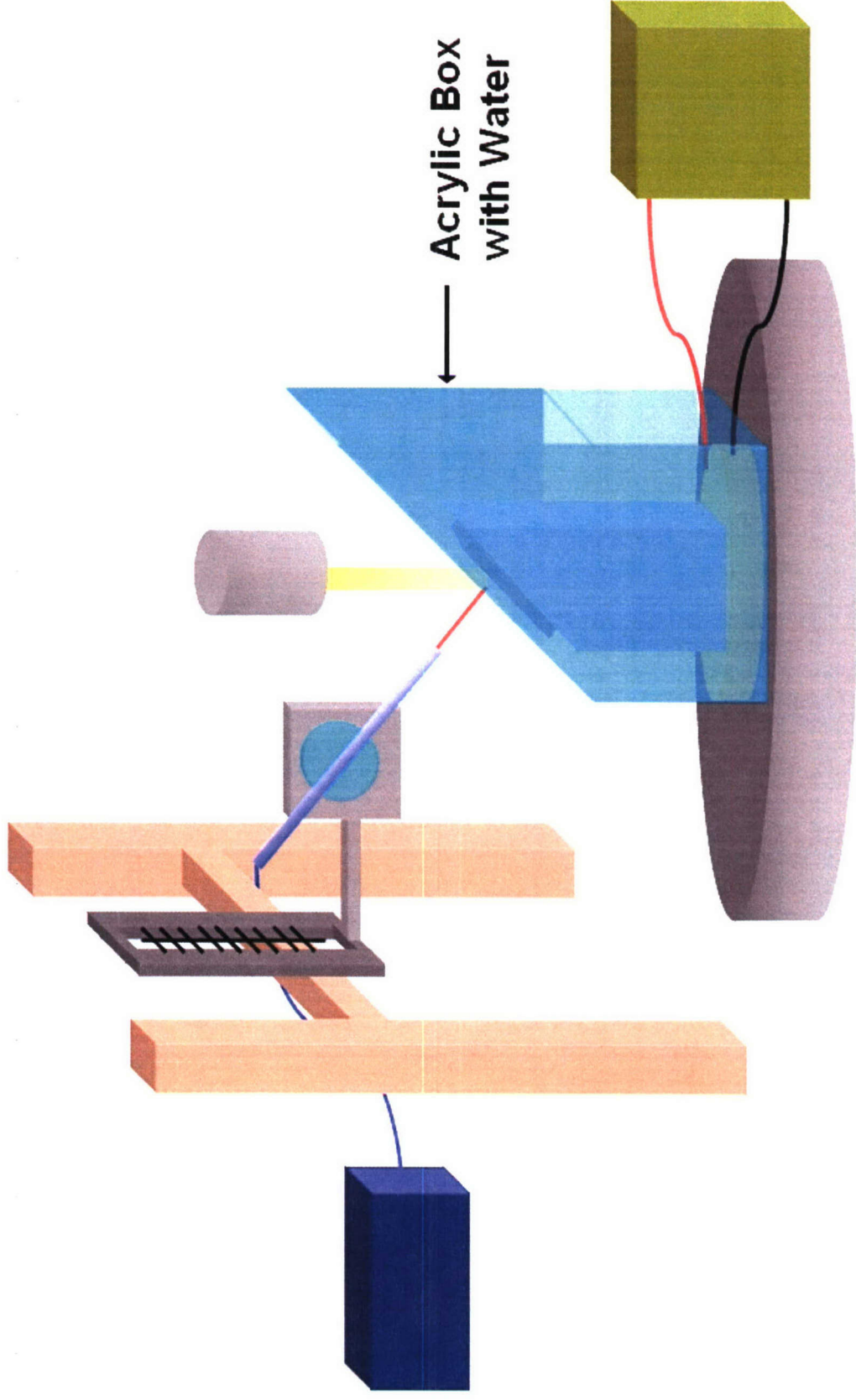
In Vacuo: 1164.6 kHz  
In Water: 570.6 kHz



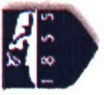
Out of plane motion

### Design 3

# S.O.W 2 - Experimental Setup for Testing in Water







## S.O.W. 2 - Experimental Results for Sensor Vibration in Water

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Performed experiments on ?? sensors

- Mean Resonant Frequency = ?? KHz
- Standard Deviation = ?? KHz



## S.O.W. 2 - Experimental Results for Sensor Vibration in Water

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Due to fluid loading the resonant frequency decreased  
from 90.037 KHz in air to ??? KHz in water.

*(Explanation and comment on applicability in water)*

## Future Proposal

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- Modify existing shear stress sensor for water tunnel experiment
  - Optical sensing will require embedding fibers.
  - Capacitive sensing will require waterproofing.